



## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

**APPLICANT:**

Menon et al.

**GROUP:** 1756**SERIAL NO:**

10/677,804

**EXAMINER:** John A. McPherson**FILED:**

October 2, 2003

**FOR:**SYSTEM AND METHOD FOR HOLOGRAPHIC FABRICATION AND  
REPLICATION OF DIFFRACTIVE OPTICAL ELEMENTS FOR  
MASKLESS LITHOGRAPHY**Commissioner of Patents****P.O. Box 1450****Alexandria, VA 22313-1450****Sir:****CHANGE OF CORRESPONDENCE ADDRESS**

Applicant's representative requests that the correspondence address for the above application be changed to:

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Respectfully submitted,

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I hereby certify that this paper (along with any paper referred to as being attached or enclosed) is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to the Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450

Meghan H. Carr  
06/15/2006  
Date